

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Den Toonder, <i>et al.</i>	Docket No.:	EPC-018
Serial No.:	10/578,027	Art Unit:	1733
Filed:	November 6, 2008	Examiner:	Janell Combs Morillo
For:	Radio-Frequency Microelectromechanical Systems and a Method of Manufacturing Such Systems		

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed December 23, 2010. Please amend the above-referenced application as follows.